



566.38683CX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Masato YOSHIDA, et al.  
Serial No.: 10/042,271  
Filed: January 11, 2002  
For: ABRASIVE METHOD OF POLISHING TARGET MEMBER AND  
PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE  
Group: 3723  
Examiner: Shantese L. McDonald

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

May 28, 2004

Sir:

In the matter of the above-identified application, Applicants hereby respectfully petition for an extension of time to permit filing a response within a two-month time period subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed December 30, 2003. A credit card payment form in the amount of \$420.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (566.38683CX1) and any excess fees credited to that account.

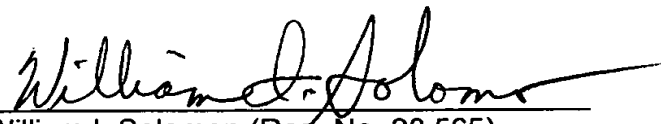
Respectfully submitted,  
ANTONELLI, TERRY, STOUT & KRAUS, LLP

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By

  
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